## Supporting Information

## Isolation of hydrazine oxidation products via halogen bonding: C–I bond scission and crystal polymorphism

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		3		
Y– <i>X</i> …A	Y–X	X…A	Y– <i>X</i> …A	
C1–I1…N1	2.0995(3)	2.9640(3)	175.27(11)	
C3–I2…N2	2.0902(3)	2.9732(3)	175.39(10)	
4				
C1–I1…N2	2.0911(4)	2.8937(4)	171.66(14)	
C5–I2…N1	2.1016(4)	2.8930(4)	175.42(15)	
		5	( ),	
C1–I1…I8	2 0831(13)	3 5736(11)	170 45(3)	
C4–I2…I8	2 0743(11)	3 5514(11)	176 84(3)	
C7–I3…I7	2.0673(11)	3.6138(12)	164.11(3)	
C7–I3…I6	2.0673(11)	4.0232(11)	117.81(3)	
C10–I4…I8	2.0894(11)	3.5364(10)	169.75(3)	
C13–I5…I7	2.0661(16)	3.4506(13)	172.55(4)	
C16–I6⋯I7	2.0629(14)	3.4109(13)	176.90(3)	
C16–I6…I3	2.0629(14)	4.0232(11)	121.67(4)	
6				
C1–I1…I5	2.0992(3)	3.5655(3)	174.11(10)	
C7–I3…I5	2.0925(3)	3.5691(3)	167.91(10)	
C9–I4…I5	2.0960(3)	3.5961(3)	177.05(10)	
		7		
C5–I2…I1	2.1014(5)	3.5186(4)	176.55(14)	
C7–I3…I1	2.0937(5)	3.6262(5)	172.77(13)	
8				
C5–I2…I1	2.1081(2)	3.5156(2)	176.79(10)	
C7–I3…I1	2.0972(2)	3.5664(2)	171.01(10)	
C11–l4…l1	2.1017(2)	3.5148(2)	174.55(10)	
C13–I5…I1	2.0918(2)	3.6731(2)	171.99(10)	
9				
C3–I18…I20	2.0987(2)	3.5575(5)	168.57(7)	
C4–I19⋯I20	2.0964(2)	3.5589(5)	166.99(6)	
10				
C3–I2···I1	2.1053(5)	3.5317(10)	171.07(14)	
C4–l3…l1	2.0949(5)	3.7556(10)	162.55(10)	
11				
C2–I1…I4	2.0850(3)	3.7492(3)	153.69(10)	
C4–I2···I4	2.0967(3)	3.4409(3)	176.13(10)	
C6–I3…I4	2.0883(3)	3.5445(3)	166.46(10)	
12				
C4–l2…l1	2.1066(4)	3.3932(4)	177.74(12)	
C6–I3…I1	2.0907(4)	3.5683(4)	167.51(12)	
C8–I4…I1	2.0821(4)	3.7193(4)	156.61(12)	

Table SI1: Selected halogen bonding parameters (Å, °)



**Figure SI1:** Unit cell packing of  $2(m-F_4DIB) \cdot (HHDMTZ)$  (3) as viewed down the *a* axis (top) and halogen bonding chains (bottom). Hydrogen atoms have been omitted for clarity. Thermal ellipsoids are shown at the 50% probability level.



**Figure SI2:** Unit cell packing of  $2(p-F_4DIB) \cdot (HHDMTZ)$  (4) as viewed down the *b* axis (top) and halogen bonding sheets (bottom). Hydrogen atoms have been omitted for clarity. Thermal ellipsoids are shown at the 50% probability level.



**Figure SI3:** Unit cell packing of  $3(p-F_4DIB) \cdot (NMe_4I)$  (5) as viewed down the *a* axis. Hydrogen atoms have been omitted for clarity. Thermal ellipsoids are shown at the 50% probability level.



**Figure SI4:** Unit cell packing of  $2(m-F_4DIB) \cdot (NMe_4I)$  (6) as viewed down the *a* axis (top) and halogen bonding ribbons (bottom). Hydrogen atoms have been omitted for clarity. Thermal ellipsoids are shown at the 50% probability level.



**Figure SI5:** Unit cell packing of  $2(m-F_4DIB) \cdot (NMe_4I)$  (7) as viewed down the *a* axis (top) and halogen bonding ribbons (bottom). Hydrogen atoms have been omitted for clarity. Thermal ellipsoids are shown at the 50% probability level.



**Figure SI6:** Unit cell packing of  $2(\mathbf{m}-\mathbf{F}_4\mathbf{DIB})\cdot(\mathbf{NMe}_4\mathbf{I})$  (8) as viewed down the *a* axis (top) and halogen bonding ribbons (bottom). Hydrogen atoms have been omitted for clarity. Thermal ellipsoids are shown at the 50% probability level.



**Figure SI7:** Unit cell packing of  $(o-F_4DIB) \cdot (NMe_4I)$  (9) as viewed down the *a* axis. Hydrogen atoms have been omitted for clarity. Thermal ellipsoids are shown at the 50% probability level.



**Figure SI8:** Unit cell packing of  $2(o-F_4DIB) \cdot (NMe_4I)$  (10) as viewed down the *c* axis (top) halogen bonding ribbons (bottom). Hydrogen atoms have been omitted for clarity. Thermal ellipsoids are shown at the 50% probability level.



**Figure SI9:** Unit cell packing of  $(135-F_3I_3B) \cdot (NMe_4I)$  (11) as viewed down the *c* axis (top) and halogen bonding sheets as viewed down the *a* axis (bottom). Hydrogen atoms have been omitted for clarity. Thermal ellipsoids are shown at the 50% probability level.





**Figure SI10:** Unit cell packing of  $(135-F_3I_3B) \cdot (NMe_4I)$  (12) as viewed down the *c* axis (top) and . halogen bonding sheets as viewed down the *b* axis (bottom). Hydrogen atoms have been omitted for clarity. Thermal ellipsoids are shown at the 50% probability level.